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FORM: PTO-1449 (REV: 7-80)	U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE	Atty Docket No: 1998-0609.02/US	Serial No: <u>Not Assigned</u>
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (37 CFR 1.98(b))		Applicant: Micron Technology, Inc.	101722791
		Filing Date: November 25, 2003	Group: <u>Not Assigned</u>

U.S. PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Name	Class	Subclass
JN	AA 4,870,470	09/1989	Bass et al.	357	23.5
	AB 5,378,659	01/1995	Roman et al.	437	229
	AC 5,656,837	08/1997	Lancaster et al.	257	314
	AD 5,719,410	02/1998	Suehiro et al.	257	77
	AE 5,781,031	07/1998	Bertin et al.	326	39
	AF 5,789,295	08/1998	Liu	438	264
	AG 5,963,806	10/1999	Sung et al.	438	266
	AH 5,981,403	11/1999	Ma et al.	438	758
	AI 5,985,771	11/1999	Moore et al.	438	791
	AJ 6,051,511	04/2000	Thakur et al.	438	791
	AK 6,069,640	05/2000	Kubatzki	438	652
	AL 6,177,311	01/2001	Kauffman et al.	438	257
	AM 6,653,683	11/2003	Rudeck et al.	257	315

FOREIGN PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Country	Class	Subclass	Translation Yes	Translation No
	AN					<input type="checkbox"/>	<input type="checkbox"/>
	AO					<input type="checkbox"/>	<input type="checkbox"/>
	AP					<input type="checkbox"/>	<input type="checkbox"/>

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OTHER ART (including author, title, date, pertinent pages, etc.)

JN	AQ	Cohen, et al. "A novel double metal structure for voltage programmable links" IEEE Electron Device Letters (Sept 1992) vol. 13, No.9, pp. 488-490.
	AR	
	AS	

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10/18/04